L Number	Hits	Search Text	DB	Tim stamp
1	1 3	shibaura.as. and mechatronics.as. and (wafer robot)	USPAT; EPO; JPO; DERWENT	2004/ 1/24 14:22
2	3	(shibaura.as. and mechatronics.as. and (wafer robot)) and linear	USPAT; EPO; JPO; DERWENT	2004/01/24 14:23
3	1663	(wafer substrate) and (process processing processor) and (linear adj motor)	USPAT; EPO; JPO; DERWENT	2004/01/24 16:59
4	302	Shinko.as. and (linear adj motor)	USPAT; EPO; JPO; DERWENT	2004/01/24 17:21
5	3	(load adj port) and robot and (linear adj motor)	USPAT; EPO; JPO; DERWENT	2004/01/24 17:22
6	81	(cassette pod) and robot and (linear adj motor)	USPAT; EPO; JPO; DERWENT	2004/01/24 17:23

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